



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EP 2813
PATENT

part of
6

In re Application of:
Ravi Iyer

Serial No.: 09/059,865

Filed: April 14, 1998

For: PLANARIZATION USING PLASMA
OXIDIZED AMORPHOUS SILICON

§ Group Art Unit: 2813

§ Examiner: Nguyen, T.

§ Atty Docket: MICS:0015--2/FLE
93-118.02

CERTIFICATE OF TRANSMISSION AND MAILING
37 C.F.R. 1.8

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Michael G. Fletcher

Sir:

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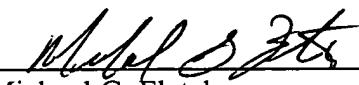
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